

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Setsuo NAKAJIMA	)	Group Art Unit: 2814
Application No. 10/752,993	)	Examiner: Shrinivas H. Rao
Filed: January 8, 2004	)	Confirmation No. 6484
For: METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	)	

**REQUEST FOR ACKNOWLEDGMENT OF  
INFORMATION DISCLOSURE STATEMENT**

MAIL STOP ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Information Disclosure Statement with Form PTO-1449 was filed in the above-identified patent application on August 25, 2008. Applicants have not yet received back from the Examiner a copy of the Form PTO-1449 initialed to acknowledge the fact that the Examiner has considered the cited disclosed information.

The Examiner is requested to initial and return to the undersigned a copy of the subject Form PTO-1449 for each of these filings.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,

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